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Dkt. 01196

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Group Art Unit: 2879

BINH VU THIEN et al

Examiner: S. Roy

Serial No.: 09/926,489

Filed: November 13, 2001

For: METHOD AND DEVICE FOR EXTRACTION OF ELECTRODES IN A
VACUUM AND EMISSION CATHODES FOR SUCH DEVICE

PETITION UNDER 37 CFR § 1.136

Honorable Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

Petition is herein made under the provisions of 37
CFR 1.136 for an extension of time for one month for response
to the Office action of September 7, 2005.

The appropriate fee set forth in 37 CFR 1.17 is paid
herewith by credit card (Form PTO-2038). Any fees not
accepted by the credit card amount shown on the Form PTO-2038
may be charged to Deposit Account 04-0753.

Respectfully submitted,

Ira J. Schultz

Ira J. Schultz
Registration No. 28666

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